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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Jiro KONDO, et al.  
Serial No. : 10/591,093  
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For : METHOD FOR REMOVING BORON FROM SILICON  
Examiner : Cohen, Stefanie J.  
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**AMENDMENT**

In response to the Final Office Action dated July 23, 2010, Applicants respectfully request entry of the following amendments and comments into the file of the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.